DOCKET NO: 245156US3CIP

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF

TSUTOMU OKABE, ET AL.

: EXAMINER: MOORE, K.

SERIAL NO: 10/706,915

FILED: NOVEMBER 14, 2003

: GROUP ART UNIT: 1792

FOR: WAFER PROCESSING

APPARATUS HAVING DUST PROOF

FUNCTION

DO NOT ENTER /KM/ (04/16/2008)

AMENDMENT UNDER 37 C.F.R. § 1.111

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated December 14, 2007, please amend the aboveidentified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.